

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:	)	
	)	
Osamu KASONO et al.	)	Confirmation No.: 3017
	)	
Application No.: 10/593,744	)	Group Art Unit: 2882
	)	
Filed: September 22, 2006	)	Examiner: Christina A. Riddle
	)	
For: EXPOSURE DEVICE	)	

Commission for Patents  
U.S. Patent and Trademark Office  
**Customer Window, Mail Stop Amendment**  
Alexandria, VA 22314

Sir:

**RESPONSE TO RESTRICTION/ELECTION REQUIREMENT**

In an Office Action dated October 14, 2009, the period for response to which runs through November 16, 2009 (November 14, 2009 being a Saturday), the Examiner required election under 35 U.S.C. §§ 121 and 372 between the claims of :

Group I (claims 7-9) allegedly drawn to an exposure device for irradiating an exposure beam to a substrate comprising a substrate mount portion, a spindle, a fluid bearing portion, and a conduit pipe for supplying cooling fluid through the fluid bearing portion and the spindle to the substrate mount portion,

Group II (claims 11-12) allegedly drawn to an exposure device for irradiating an exposure beam to a substrate comprising a substrate mount portion, an irradiating portion, and a

low temperature member that is disposed at the exposure surface side of the substrate and at the rotational downstream side of the irradiation position of the exposure beam,

Group III (claims 13-16) allegedly drawn to an exposure device for irradiating an exposure beam to a substrate comprising a substrate holding portion, a driving portion for varying the irradiation position, and an air blower for feeding air to the irradiation position of the exposure beam during irradiation of the exposure beam to cool the irradiation position, and

Group IV (claims 17-21) allegedly drawn to an exposure device for irradiating an exposure beam to a substrate comprising a substrate holding portion, a driving portion for rotating and translating the substrate, a cooling portion for cooling the substrate, an irradiation position detector for detecting the irradiation position of the exposure beam, a plurality of temperature detectors arranged along the radial direction of the substrate for detecting the temperature of the substrate, and a temperature controller for controlling the temperature of the irradiation position on the basis of the temperature detected by the plurality of temperature detectors.

Applicants hereby elect Group I (claims 7-9) for examination.

Applicants respectfully request formal examination of this application.

Applicants respectfully submit that no fee is due in connection with the filing of this response. However, if there are any fees due in connection with the filing of this response, **except** for issue fees payable under 37 C.F.R. § 1.18, the Commissioner is hereby authorized by this paper to charge any such fees during the entire pendency of this application, including fees

due under 37 C.F.R. §§ 1.16 and 1.17 which may be required and including any required extension of time fees, *or* credit any overpayment to Deposit Account No. 50-0573. This paragraph is intended to be a **CONSTRUCTIVE PETITION FOR EXTENSION OF TIME** in accordance with 37 C.F.R. § 1.136(a)(3).

Respectfully submitted,

**DRINKER, BIDDLE & REATH LLP**

Dated: October 27, 2009

By:

A handwritten signature in black ink, appearing to read "Paul A. Fournier", written over a horizontal line.

Paul A. Fournier

Reg. No. 41,023

**Customer No. 055694**

**DRINKER, BIDDLE & REATH LLP**

1500 K Street, N.W., Suite 1100

Washington, D.C. 20005-1209

Tel: (202) 842-8800

Fax: (202) 842-8465